



UNITED STATES PATENT AND TRADEMARK OFFICE

**UNITED STATES DEPARTMENT OF COMMERCE**  
**United States Patent and Trademark Office**  
 Address: **COMMISSIONER FOR PATENTS**  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
[www.uspto.gov](http://www.uspto.gov)



## Bib Data Sheet

**CONFIRMATION NO. 1737**

SERIAL NUMBER 10/631,238	FILING DATE 07/31/2003  RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 29936/39433		
<b>APPLICANTS</b>  Sung Hoon Lee, Seoul, KOREA, REPUBLIC OF;  ** CONTINUING DATA ***** None LV  ** FOREIGN APPLICATIONS ***** Y19L LV REPUBLIC OF KOREA 2002-68678 11/07/2002  IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/25/2003						
Foreign Priority claimed  35 USC 119 (a-d) conditions met  Verified and Acknowledged		<div style="display: flex; justify-content: space-between;"><div><input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance</div><div>Examiner's Signature <i>[Signature]</i> Initials <i>LV</i></div></div>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS  DRAWING 4	TOTAL  CLAIMS 11	INDEPENDENT  CLAIMS 1
<b>ADDRESS</b> 04743 MARSHALL, GERSTEIN & BORUN LLP 233 S. WACKER DRIVE, SUITE 6300 SEARS TOWER CHICAGO , IL 60606						
<b>TITLE</b> Method of forming an isolation film in a semiconductor device						
FILING FEE  RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<div style="border: 1px solid black; padding: 2px;"><input type="checkbox"/> All Fees</div> <div style="border: 1px solid black; padding: 2px;"><input type="checkbox"/> 1.16 Fees ( Filing )</div> <div style="border: 1px solid black; padding: 2px;"><input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )</div>		